

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

APPLICANT: Maud Vinet et al.  
SERIAL NO.: 10/539,532  
FILING DATE: June 17, 2005 CONFIRMATION No.: 4554  
TITLE: Method For Forming Patterns Aligned On Either Side Of A Thin Film  
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KCC 5/16/2008

**AMENDMENT AND RESPONSE AFTER FINAL OFFICE ACTION UNDER**

**37 CFR 1.116**

Dear Sir:

This paper is responsive to the Advisory Action mailed April 30, 2008. Please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims, which begins on page **2** of this paper.

**Remarks** begin on page **5** of this paper.